

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q62228

RECEIVED

Yoshihisa FURUTA, et al.

FEB 1 9 2003

Appln. No.: 09/719,422

Group Art Unit: 1733

TC 1700

Confirmation No.: 7788

Examiner: Barbara J. MUSSER

Filed: December 12, 2000

For:

METHOD OF RESIN ENCAPSULATING SEMICONDUCTOR CHIP AND

PRESSURE-SENSITIVE ADHESIVE TAPE FOR ADHESION TO LEADFRAME

AND THE LIKE

SUBMISSION OF DRAWINGS

Commissioner for Patents Washington, D.C. 20231

Sir:

Submitted herewith please find 1 sheet of drawing in compliance with 37 C.F.R. § 1.84.

The Examiner is respectfully requested to acknowledge receipt of this drawing.

The submitted drawing incorporates the proposed drawing changes approved in Paper

No. 9.

Respectfully submitted,

SUGHRUE MION, PLLC

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WASHINGTON OFFICE

Date: February 12, 2003

Registration No. 32,607